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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademar Office at Fax number 703 305 3432 on April 2, 2003.

Mary Ann Oppas. Secretary

In the Application of Wilfred Lerch et al

Ser.No.:

09/980,754

Filed:

February 15, 2002

For:

METHOD OF GENERATING DEFECTS IN A LATTICE STRUCTURE

OF A SEMI-CONDUCTOR MATERIAL

Art Unit:

2823

FAX RECEIVED

Examiner:

Julio J. Maldonado

APR 2 2003

Assistant Commissioner for Patents

TECHNOLOGY CENTER 2800

Washington, DC 20231

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION DATED 12/03/2002

Dear Sir:

In response to the outstanding Office Action, please amend the above-identified application as follows:

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